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LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Applicant: Jay Schwichtenberg et al.	
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Examiner Initial	Document No.	Date	Name	
202	3,877,075	04/1975	Watanabe	
202	2002/020773-A1	02/2002	Fuji Hiroshi et al.	
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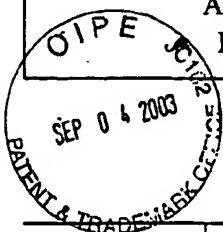
OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER: <u>G. Bradley Bennett</u>	DATE CONSIDERED: <u>22 Nov 2004</u>

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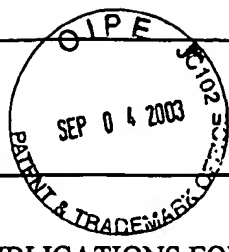
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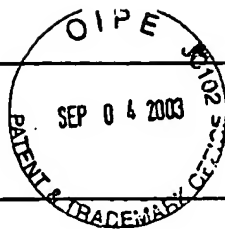
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202	DE 19617852	01/1993	DE	Abstract
↓	EP 0744821 A2	11/27/1996	EP	
	EP 0744821 A3	12/04/1996	EP	
	EP 1001326	05/27/1999	EP	
	JP 02-86258	10/1995	JP	Abstract
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	SU 744877	06/1980	SU	Abstract
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